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CONFIRMATION NO. 7

Bib Data Sheet

SERIAL NUMBER 10/706,915	FILING DATE 11/14/2003  RULE	CLASS 156	GROUP ART UNIT 1763	ATTORNEY DCKE NO. 245156US3CIP
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## APPLICANTS

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## \*\* CONTINUING DATA \*\*\*\*\*

This application is a CIP of 10/330,092 12/30/2002

✓  
ku  
3/8/05

## \*\* FOREIGN APPLICATIONS \*\*\*\*\*

NONE  
ku 3/8/05

## F REQUIRED, FOREIGN FILING LICENSE GRANTED

\*\* 04/14/2004

Foreign Priority claimed <input type="checkbox"/> yes <input checked="" type="checkbox"/> no	STATE OR	SHEETS	TOTAL	INDEPENDE
35 USC 119 (a-d) conditions met <input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after Allowance	COUNTRY	DRAWING	CLAIMS	CLAIMS
Verified and Acknowledged Examiner's Signature <i>klone</i> Initials <i>ku</i>	JAPAN	7	6	2

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## TITLE

Wafer processing apparatus having dust proof function

FILING FEE

RECEIVED  
900

FEES: Authority has been given in Paper  
No. \_\_\_\_\_ to charge/credit DEPOSIT ACCOUNT  
No. \_\_\_\_\_ for following:

☐ All Fees☐ 1.16 Fees ( Filing )☐ 1.17 Fees ( Processing Ext. of time☐ 1.18 Fees ( Issue )